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Bib Data Sheet

CONFIRMATION NO. 4799

SERIAL NUMBER 10/689,617		FILING OR 371(c)	C	CLASS 438	GROUP ART UNI 1765		UNIT	ATTORNEY DOCKET NO. 12732-170001		
APPLICANTS										
Satoru Okamoto, Isehara, JAPAN;										
** CONTINUING DATA **********************************										
** FOREIGN APPLICATIONS ************************************										
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 01/17/2004										
				STATE OR COUNTRY JAPAN	SHEETS DRAWING 9		TOTAL CLAIMS 95		INDEPENDENT CLAIMS 13	
ADDRESS 26171										
TITLE Method for cleaning plasma etching apparatus, method for plasma etching, and method for manufacturing semiconductor device										
						☐ All Fees				
						1.16 Fees (Filing)				
RECEIVED	. FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT				1.17 Fees (Processing Ext. of time)					
2980	No for following:					☐ 1.18 Fees (Issue)				
						Other				
						☐ Credit				